IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No.: 7371
Shunpei YAMAZAKI et al.)	
Application No. 09/295,607)	Examiner: Shouixiang Hu
Filed: April 22, 1999)	Group Art Unit: 2811
For: Semiconductor Device Having Aluminum Nitride Film)	Date: December 1, 2008
)	

INFORMATION DISCLOSURE STATEMENT

Mail Stop **AMENDMENT** Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. No copy of the U.S. Patent documents have been supplied with this Information Disclosure Statement in accordance with the Official Gazette Notice dated August 5, 2003. Pursuant to 37 C.F.R. § 1.98, a copy of each of the other documents cited is enclosed.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form and return it to the undersigned.

The Commissioner is hereby authorized to charge the fees, in the amount of \$180.00, connected with this filing, which are required now, in compliance with the provisions of 37 C.F.R. § 1.97(c), or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By: <u>/Sean A. Pryor, Reg. #48103/</u> Sean A. Pryor

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